CERTIFICATE OF MAILING
I horeby certify that this paper and every paper referred to therein as being enclosed in deposited with the U.S. Postal Service as first class mail, postage prepaid, in an envelope addressed to Assistant Commissioner for Putents, Washington, D.C. 20291, on Mailington, D.C. 20291, on Mailington D.C. 20291,



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PATENT

Attorney Docket No. 306 C09 M&W No. APM/063-97-CPA-CN1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: JIAN DING)) Group Art Unit: Unknown `
Entitled: LOW CEILING TEMPERATURE PROCESSOR FOR A PLASMA REACTOR WITH HEATED SOURCE OF A POLYMER-HARDENING PRECURSOR MATERIAL) Examiner: Unknown)) .
Serial No.: 10/002,397 ∮)
Filing Date: October 31, 2001	<i>)</i>)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each document is enclosed unless indicated otherwise. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace

Registration No. 29,119 Attorney for Applicants

MICHAELSON & WALLACE 2112 Eastman Avenue, Suite 102 Ventura, CA 93003 (805) 644-4035 JAN 2 5 2002

INFORMATION DISCLOSURE

CITATION FORM FOR PATENT APPLICATION (FORM PTO - 1449)

Docket No.: 306 C09

Serial No.: 10/002,397

Applicant(s): JIAN DING

Filing Date:

10-31-01

Group: UNKNOWN

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Initials	Patent No	Issue Date	Name	Class	Subclass	Filing Date
	4,786,359	11-22-88	STARK ET AL.	156	643	06-24-98
	4,948,750	08-14-90	KAUSCHE ET AL.	437	101	03-13-89
	5,074,456	12-24-91	DEGNER ET AL.	228	121	09-18-90
	5,770,099	06-23-98	RICE ET AL.	216	68	07-18-95
	5,880,036	03-09-99	BECKER ET AL.	438	740	11-15-93
	5,888,414	03-30-99	COLLINS ET AL.	216	68	09-24-97
	5,990,017	11-23-99	COLLINS ET AL.	438	714	06-25-98
	6,036,877	03-14-00	COLLINS ET AL.	216	68	05-13-96

FOREIGN PATENT DOCUMENTS

Initials	Document Number	Date	Country	Name	Translation? (Yes/No/n/a)
;	EP 0 601 468 A1	15.06.94	EUROPE	KENNETH COLLINS, ET AL.	N/A
	EP 0 650 182 A1	26.04.95	EUROPE	MICHAEL RICE, ET AL.	N/A
	EP 0 802 560 A1	01.12.92	EUROPE	KENNETH COLLINS, ET AL.	N/A
	EP 0 807 952 A2	19.11.97	EUROPE	KENNETH COLLINS, ET AL.	N/A

Initials Other Documents (Title, Author, Date, Pages, Etc., if known)

> PATENT ABSTRACTS OF JAPAN, Publication No. 62012129, Publication Date January 21, 1987 (HITACHI LTD)

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).